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10586187 GAU: 1795

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Application Number	10/586,187
				Filing or 371(c) Date	July 31, 2007
				First Named Inventor	Toru KIMURA
				Group Art Unit	1795
				Examiner Name	Unassigned
Sheet	1	of	1	Attorney Docket Number	01115 1013

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
	AA	3,895,949		Akamatsu et al.	07-22-1975	
	AB	2003/0232940		Komoriya et al.	12-18-2003	
	AC	2003/0078352		Miyazawa et al.	04-24-2003	

OTHER ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	AD	Switkes et al., Extending optics to 50 nm and beyond with Immersion lithography, Journal of Vacuum Science and Technology: Part B, AVS/AIP, Nov/Dec 2003, Pages 2794-2799, American Vacuum Society, Melville, NY, US.	

Examiner Signature	/Connie Johnson/ (04/09/2010)	Date Considered	04/09/2010
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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